



#12/A  
6-02  
Mellish  
PATENT

Customer No. 22,852  
Attorney Docket No. 08038.0024

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Noriaki FUKIAGE ) Group Art Unit: 2811  
Serial No.: 09/657,055 ) Examiner: H. Vu  
Filed: September 7, 2000 )  
For: SEMICONDUCTOR DEVICE AND )  
METHOD OF MAKING THE SAME )

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

**AMENDMENT**

In reply to the Office Action dated January 15, 2002, the period for reply having been extended for two months by a request for extension and fee payment filed concurrently herewith, please amend the application as follows:

**IN THE TITLE:**

Please change the title to read --SEMICONDUCTOR DEVICE HAVING MULTILAYER INTERCONNECTION STRUCTURE AND METHOD OF MAKING THE SAME--.

**IN THE SPECIFICATION:**

Please amend the paragraph beginning at line 11 of page 1 and ending at line 17 of page 1 as follows:

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JUN - 7 2002  
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